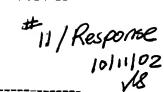
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I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING TRANSMITTED VIA FACSIMILE TO THE COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231, ON

Date of Deposit: October 8, 2002 Name of Person Making Deposit: Linda Gray

Signature: Finds Bray 19/08/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE	
In Re Application of: M. Khare et al.	October 8, 2002
	Examiner: Fernando L. Toledo
Serial No. 09/809,663 Filing Date: March 15, 2001	Group Art Unit: 2823
Title: METHOD FOR IMPROVED PLASMA NITRIDATION OF ULTRA THIN GATE DIELECTRICS	IBM Corporation 2070 Route 52 Dept. 18G, Bldg. 300-482 Hopewell Junction, N.Y. 12533

AMENDMENT UNDER 37 C.F.R. § 1.116

The Commissioner for Patents Washington, D.C. 20231

Attn: Box AF

FAX COPY RECEIVED

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Sir:

TECHNOLOGY CENTER 2800

In response to the final Office Action mailed August 8, 2002, Applicants respectfully request entry of the following remarks into the file of the above-identified application.